

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

Docket No.: Q96773

Takeyoshi KANO, et al.

Appln. No.: 10/594,227

Group Art Unit: 1773

Confirmation No.: 3397

Examiner: Carl J. ARBES

Filed: September 25, 2006

For: METHOD FOR FORMING SURFACE GRAFT, METHOD FOR FORMING
CONDUCTIVE FILM, METHOD FOR FORMING METHOD PATTERN, METHOD
FOR FORMING MULTILAYER WIRING BOARD, SURFACE GRAFT MATERIAL,
AND CONDUCTIVE MATERIAL

RESPONSE TO RESTRICTION REQUIREMENT

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

This responds to the Restriction Requirement dated February 21, 2008. In response to the Restriction Requirement, Applicant elects Group III (claims 8-10, 14, 17, and 20) for examination. This election is made without traverse.

Applicant reserves the right to file a Divisional Application directed to non-elected subject matter.

The USPTO is directed and authorized to charge all required fees, except for the Issue Fee and the Publication Fee, to Deposit Account No. 19-4880. Please also credit any overpayments to said Deposit Account.

Respectfully submitted,

/Brett S. Sylvester/

Brett S. Sylvester
Registration No. 32,765

SUGHRUE MION, PLLC
Telephone: (202) 293-7060
Facsimile: (202) 293-7860

WASHINGTON OFFICE

23373

CUSTOMER NUMBER

Date: March 13, 2008